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PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2

EPAS ID: PAT4143746

| SUBMISSION TYPE: | NEW ASSIGNMENT |
|-----------------------|----------------|
| NATURE OF CONVEYANCE: | ASSIGNMENT |

CONVEYING PARTY DATA

| Name | Execution Date |
|-----------------------|----------------|
| HOWARD E. RHODES | 10/13/2003 |
| RICHARD A. MAURITZSON | 10/13/2003 |
| INNA PATRICK | 10/14/2003 |

RECEIVING PARTY DATA

| Name: | MICRON TECHNOLOGY, INC. | |
|-----------------|-------------------------|--|
| Street Address: | 8000 SOUTH FEDERAL WAY | |
| City: | BOISE | |
| State/Country: | IDAHO | |
| Postal Code: | 83706 | |

PROPERTY NUMBERS Total: 1

| Property Type | Number |
|----------------|---------|
| Patent Number: | 7749798 |

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using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

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SEMICONDUCTOR COMPONENTS INDUSTRIES, LLC **Correspondent Name:**

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Address Line 2: MAILDROP A700

PHOENIX, ARIZONA 85008 Address Line 4:

| ATTORNEY DOCKET NUMBER: | APT2002-0951D01 | |
|-------------------------|--------------------|--|
| NAME OF SUBMITTER: | SHARRON CASTILLO | |
| SIGNATURE: | /Sharron Castillo/ | |
| DATE SIGNED: | 11/15/2016 | |

Total Attachments: 4

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PATENT REEL: 040329 FRAME: 0642



ASSIGNMENT AND AGREEMENT

For value received, we, Howard E. Rhodes; Richard A. Mauritzson; and Inna Patrick, hereby sell, assign and transfer to Micron Technology, Inc., a corporation of the State of Delaware, having an office at 8000 S. Federal Way, Boise, Idaho 83706-9632, U.S.A., and its successors, assigns and legal representatives, the entire right, title and interest, for the United States of America, in and to certain inventions related to an invention entitled AN OPTIMIZED PHOTODIODE PROCESS FOR IMPROVED TRANSFER GATE LEAKAGE, described in an application for Letters Patent of the United States, executed by us of even date herewith, and all the rights and privileges in said application and under any and all Letters Patent that may be granted in the United States for said inventions; and we also concurrently hereby sell, assign and transfer to Micron Technology, Inc. the entire right, title and interest in and to said inventions for all countries foreign to the United States, including all rights of priority arising from the application aforesaid, and all the rights and privileges under any and all forms of protection, including Letters Patent, that may be granted in said countries foreign to the United States for said inventions.

We authorize Micron Technology, Inc. to make application for such protection in its own name and maintain such protection in any and all countries foreign to the United States, and to invoke and claim for any application for patent or other form of protection for said inventions, without further authorization from us, any and all benefits, including the right of priority provided by any and all treaties, conventions, or agreements.

We hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any document which may be required in any country in proof of the right of Micron Technology, Inc. to apply for patent or other form of protection for said inventions and to claim the aforesaid benefit of the right of priority.

We request that any and all patents for said inventions be issued to Micron Technology, Inc. in the United States and in all countries foreign to the United States, or to such nominees as Micron Technology, Inc. may designate.

1651222 v1; Z#3@011.DOC

We agree that, when requested, we shall, without charge to Micron Technology, Inc. but at its expense, sign all papers, and do all acts which may be necessary, desirable or convenient in connection with said applications, patents, or other forms of protection.

United States of America

State of Idaho County of Ada

On this 13th day of October, 2003, before me personally came Howard E. Rhodes, to me known to be the individual described in and who executed the foregoing instrument, and acknowledged execution

of the same.

1651222 v1; Z#3@011.DOC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ASSIGNMENT AND AGREEMENT

Signature Page for Second Inventor

| | RILAMET |
|--|--|
| | Richard A. Mauritzson |
| Date: 10/13/03 | |
| United States of America) | |
| State of Idaho) ss.: | |
| County of Ada) | |
| On this B day of October personally came Richard A. Mauritzson | , <u> </u> |
| A, 7 | |
| described in and who executed the foregoing | instrument, and acknowledged execution |
| of the same. | 1 . 0 . |
| Manufacture of the state of the | Jose Kinendon |
| OTAP! | Notary Public |
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ASSIGNMENT AND AGREEMENT

Signature Page for Third Inventor

| | Inna Padricic |
|---|--|
| | Inna Patrick |
| Date: 10/14/2003 | |
| United States of America) State of Idaho) ss. County of Ada) | : |
| personally came Inna Patrick | to me known to be the individual sing instrument, and acknowledged execution |
| of the same. | L Loui Bissenden |
| OTAR L | Notary Public |

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PATENT **REEL: 040329 FRAME: 0646**

RECORDED: 11/15/2016